

# Supplementary information to: Global optimization of an encapsulated Si/SiO<sub>2</sub> L3 cavity with a 43 million quality factor

J.P. Vasco<sup>1,\*</sup> and V. Savona<sup>1</sup>

<sup>1</sup>Institute of Physics, École Polytechnique Fédérale de Lausanne (EPFL), CH-1015 Lausanne, Switzerland  
\*juan.vasco@epfl.ch

## 1 Optimal parameters of the encapsulated L3 cavity

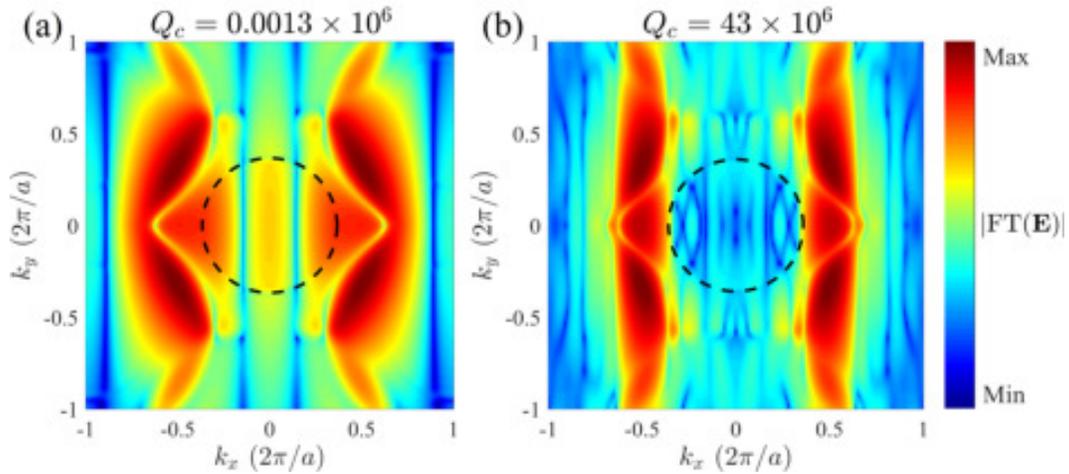
The optimal 27 parameters of the Si/SiO<sub>2</sub> L3 cavity with an FDTD quality factor of  $Q_c = 4.33 \times 10^7$  are reported in Table 1.

**Table 1.** Optimal parameters of the Si/SiO<sub>2</sub> L3 cavity with  $Q_c = 4.33 \times 10^7$

Parameter/Hole	1	2	3	4	5	6	7	8	9	10
$dx$	0.4407	0.3817	0.3936	0.3352	0.3097	0.1385	×	×	×	0.0010
$dy$	×	×	×	×	×	×	0.0109	0.0107	0.0082	×
$dr$	-0.1500	-0.1500	-0.0772	-0.1075	-0.0690	-0.0672	×	×	×	×
Parameter/Hole	11	12	13	14	15	16	17	18	19	20
$dx$	×	×	-0.0044	×	×	0.0010	0.0018	0.0017	×	×
$dy$	0.0027	×	0.0121	-0.0010	×	×	-0.0044	-0.0081	-0.0071	×
$dr$	×	0.0001	×	×	×	×	×	×	×	×

## 2 Fourier transform of near-field components

The far-field projections of the mode components for the non-optimized and optimized cavities, are shown in Figs. 1(a) and 1(b), respectively, in log scale. This projection is obtained through the Fourier transform of the near-field components<sup>1</sup>, recorded in a  $xy$  plane localized at 90 nm above the photonic crystal surface. The dashed circle represents the region where the cavity frequency crosses the light-line. The strong reduction of the field components inside the light cone (or equivalently, above the light-line) is clearly seen for the optimized design.



**Figure 1.** (a) Far-field of the non-optimized cavity. (b) same as (a) for the optimized design. The dashed circle represents the region where the cavity frequency crosses the light-line of the dielectric slab.

### 3 Results for the Si/Air L3 cavity

The Si/Air (air-bridge) L3 cavity is considered in a silicon PC with a hexagonal lattice of holes with radii  $r = 100$  nm, lattice parameter  $a = 400$  nm and slab thickness  $d = 220$  nm. The PS optimization is carried out by considering the same 27 parameters of the Si/SiO<sub>2</sub> case.

#### 3.1 Optimal figures of merit

We show in Table 2 the linear and non-linear figures of merit of both, non-optimized and optimized designs. The quality factor is improved by four orders of magnitude with a final FDTD value of  $Q_c = 1.91 \times 10^8$ , which is around 20 times larger than the previous best, for the silicon L3 cavity, obtained with deep learning optimization techniques<sup>2</sup>.

**Table 2.** Linear and non-linear figures of merit for the non-optimized and optimized Si/Air L3 cavities.

Si/Air – L3 cavity	$f$ (Thz)	$Q_c$	$V_l (\lambda/n_{Si})^3$	$V_{nl} (\lambda/n_{Si})^3$	$Q_c/V_l (n_{Si}/\lambda)^3$	$Q_c^2/V_{nl}^2 (n_{Si}/\lambda)^6$
Non-optimized	196.3	$6.53 \times 10^3$	0.59	2.48	$1.10 \times 10^4$	$6.94 \times 10^6$
Optimized	193.6	$1.91 \times 10^8$	1.07	4.30	$1.78 \times 10^8$	$1.97 \times 10^{15}$

#### 3.2 Optimal parameters

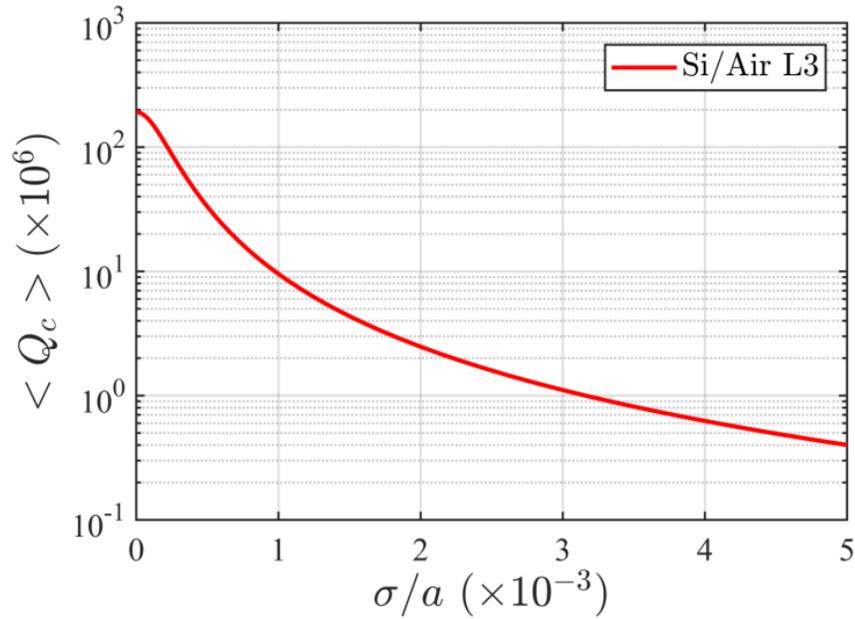
The optimal parameters for the Si/Air L3 cavity with  $Q_c = 1.91 \times 10^8$  are reported in Table 3

**Table 3.** Optimal parameters of the Si/Air L3 cavity with  $Q_c = 1.91 \times 10^8$

Parameter/Hole	1	2	3	4	5	6	7	8	9	10
$dx$	0.3800	0.2954	0.2000	0.4032	0.2360	0.0475	×	×	×	-0.0179
$dy$	×	×	×	×	×	×	-0.0232	-0.0157	0.0028	×
$dr$	-0.0445	-0.0174	0.0033	-0.0433	-0.1500	-0.0805	×	×	×	×
Parameter/Hole	11	12	13	14	15	16	17	18	19	20
$dx$	×	×	-0.0341	×	×	0.0040	-0.0001	-0.0059	×	×
$dy$	-0.0600	×	-0.0141	-0.0078	×	×	0.0083	-0.0114	-0.0307	×
$dr$	×	-0.0427	×	×	×	×	×	×	×	×

#### 3.3 Disorder analysis

Figure 2 show the disorder analysis for the optimal air-bridge L3 cavity. An averaged  $Q_c$  in the 4 million regime is predicted for typical tolerances, ranging between  $\sigma = 0.001a$  and  $\sigma = 0.002a$ , in silicon fabrication techniques<sup>3,4</sup>.



**Figure 2.** Averaged  $Q_c$ , computed over 100 independent disorder realizations of the optimal Si/Air cavity, as a function of the disorder parameter  $\sigma$ .

## References

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